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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chihiro KAWAI, et al.

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE

Application No.: 10/500,975

Customer No.: 20277
Confirmation No.: 3373

Filed: July 08, 2004

Examiner: Andrew O. Arena

Group Art Unit: 2811

Title: POROUS SEMICONDUCTOR AND METHOD FOR MANUFACTURING SAME

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Remarks and Amendment are submitted in response to the Office Action
dated February 7, 2007.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 15 of this paper.

Do Not Enter
A.O.A. 25 June 2006

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